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On : MARCH 31, 2004

By:

LINDA E. HASTINGS

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

**Attorney Docket No.: NECK 17.552 (100806-17282)**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: Hiroshi TANABE  
Serial No.: 09/614,286  
Filed: July 12, 2000  
Title: **METHOD FOR FORMING SEMICONDUCTOR FILMS  
AT DESIRED POSITIONS ON A SUBSTRATE**  
Examiner: Erik J. Kielin  
Group Art Unit: 2813

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**PETITION FOR EXTENSION OF TIME**

S I R :

Applicant requests that the time for taking action in this case be extended pursuant to 37 CFR 1.136(a) for:

☐ one month ☒ **three months**

☐ two months ☐ four months

The fee set in 37 CFR 1.17 for the extension of time is \$950.00.

04/02/2004 AWONDAF1 00000076 501290 09614286

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☐ Fee enclosed. Please charge any additional fee required for this extension of time to Deposit Account No. 50-1290. A duplicate copy of this paper is enclosed.

☒ **Charge fee to Deposit Account No. 50-1290. A duplicate copy of this paper is enclosed.**

☐ Applicant is a small entity entitled to pay reduced fees in this application. A verified small entity statement:

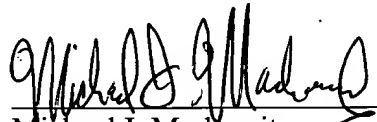
☐ has been filed ☐ is enclosed

Also enclosed is a:

☒ **Response to Official Action**

☐ Notice of Appeal ☐ Appeal Brief

Respectfully submitted,

  
Michael I. Markowitz  
Reg. No. 30,659

**CUSTOMER NO.: 026304**

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ATTORNEY DOCKET NO.:NECK 17.552

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